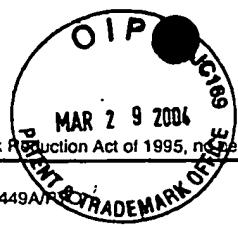


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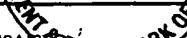


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 INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				<i>Complete if Known</i>	
Substitute for Form 1449A/PUSPTO TRADEMARK OFFICE		Application Number	10/737,363		
		Filing Date	December 16, 2003		
		First Named Inventor	Clark T.-C. Nugyen, et al.		
		Group Art Unit	2817		
		Examiner Name	Barbara Summons		
Sheet	1	of	3	Attorney Docket Number	
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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

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⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Substitute for Form 1449B/PTO				<i>Complete if Known</i>	
				Application Number	10/737,363
				Filing Date	December 16, 2003
				First Named Inventor	Clark T.-C. Nguyen, et al.
				Group Art Unit	2817
				Examiner Name	<i>Barbara Summons</i>
Sheet	2	of	3	Attorney Docket Number	UOM 0285 PUSP

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>BS</i>	-	NGUYEN, CLARK, T.-C., Microelectromechanical Components For Miniaturized Low-Power Communications, Proceedings, 1999 IEEE MTT-S International Microwave Symposium RF MEMS Workshop, Anaheim, California, June 18, 1999, pp. 48-77	
<i>BS</i>	-	NGUYEN, CLARK, T.-C., Micromechanical Circuits For Communication Transceivers, Proceedings, 2000 Bipolar/BiCMOS Circuits and Technology Meeting (BCTM), Minneapolis, Minnesota, September 25-26, 2000, pp. 142-149	
<i>BS</i>	-	TANG, WILLIAM C., ET AL., Laterally Driven Polysilicon Resonant Microstructures, Sensors and Actuators, Vol. 20, 1989, Abstract only	
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<i>BS</i>	-	WANG, KUN, ET AL., High-Order Medium Frequency Micromechanical Electronic Filters, IEEE, Journal of Microelectromechanical Systems, Vol. 8, No. 4, December 1999, pp. 534-557	
<i>BS</i>	-	BANNON, FRANK D., ET AL., High-Q HF Microelectromechanical Filters, IEEE Journal of Solid-State Circuits, Vol. 35, No. 4, April 2000, pp. 512-526	
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Examiner Signature	<i>Barbara Summons</i>	Date Considered	4/4/05
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				Examiner Name	Barbara Summons
Sheet	3	of	3	Attorney Docket Number	UOM 0285 PUSP

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BS		HSU, WAN-THAI, ET AL., A Sub-Micron Capacitive-Gap Process For Multiple-Metal-Electrode Lateral Micromechanical Resonators, Technical Digest, IEEE Int. Micromechanical Systems Conf., Interlaken, Switzerland, January 21-25, 2001, pp. 349-352	
BS		WAKE, R. N., ET AL., Changes In The Natural Frequencies of Repeated Mode Pairs Induced By Cracks In A Vibrating Ring, IEEE Journal of Sound and Vibration, Vol. 214, No. 4, November 1998, pp. 761-770	
BS		DEMIRCI, MUSTAFA U., ET AL., Mechanically Corner-Coupled-Square Microresonator Array For Reduced Series Motional Resistance, Digest of Papers Int. Conf. on Solid-State Sensors and Actuators, Transducers 2003, June 8-12, 2003	
BS		CLARK, JOHN R., ET AL., High-Q UHF Micromechanical Radial-Contour Mode Disk Resonators; submitted for publication in IEEE Journal of Microelectromechanical Systems on April 29, 2003, pp. 1-10	
BS		FUJITA, T., ET AL., Disk-Shaped Bulk Micromachined Gyroscope With Vacuum Sealing, Sensors and Actuators, Vol. 82, May 2000, pp. 198-204	

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